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CA 94568 (US). TAO, Xianzhi; 4217 McKellar Lane #5A,
Campbell, CA 94306 (US). CHEN, Steven, A.; 2278 Quail
Bluff, San Jose, CA 95121 (US).

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(74) Agent: ADLER, Benjamin, A.; Adler & Associates, 8011
Candle Lane, Houston, TX 77071 (US).

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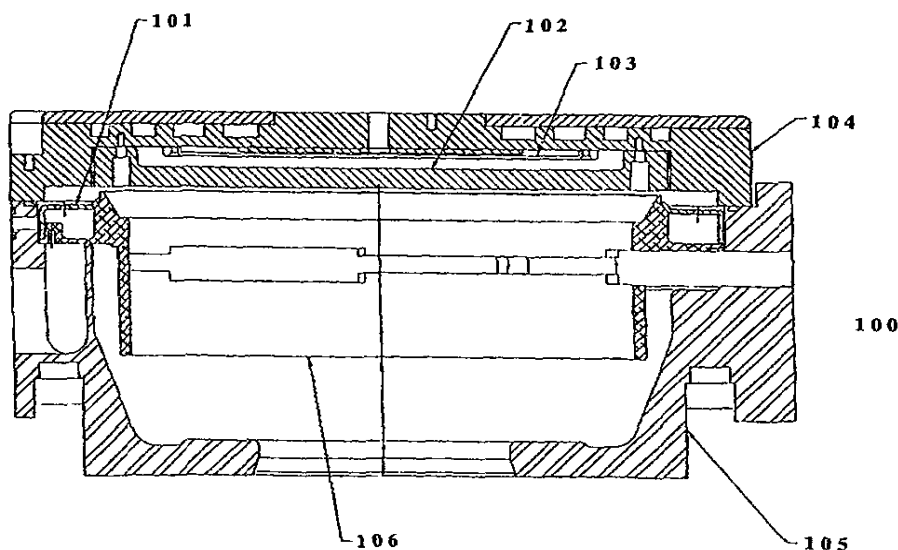
(71) Applicant: APPLIED MATERIALS [US/US]; 2881
Scott Blvd., Mailstop 2061, Santa Clara, CA 95051 (US).

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(72) Inventors: LUO, Lee; 222 Brunswick Place, Fremont, CA
94539 (US). HO, Henry; 6906 Lenwood Way, San Jose,
CA 95120 (US). WANG, Shulin; 959 Steinway Avenue,
Campbell, CA 95008 (US). TRAN, Binh, Hoa; 5528 Spin-
naker Drive #1, San Jose, CA 95123 (US). TAM, Alexan-
der; 2451 Balmoral Street, Union City, CA 94587 (US).
SANCHEZ, Errol, A., C.; 5291 Gilford Court, Dublin,

For two-letter codes and other abbreviations, refer to the "Guid-
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ning of each regular issue of the PCT Gazette.

(54) Title: EMISSIVITY-CHANGE-FREE PUMPING PLATE KIT IN A SINGLE WAFER CHAMBER



(57) Abstract: Provided herein is an emissivity-change-free pumping plate kit used in a single wafer chamber (105). This kit comprises a top open pumping plate (106), and optionally a skirt and/or a second stage choking plate (101). The skirt may be installed around wafer heater, underneath wafer heater, or along chamber body inside the chamber. The choking plate is installed downstream of the top open pumping plate along the purge gas flow. Also provided is a method of preventing emissivity change and further providing optimal film thickness uniformity during wafer processing by utilizing such kit in the chamber.

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A. CLASSIFICATION OF SUBJECT MATTER

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B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

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Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, PAJ

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	EP 0 909 836 A (EBARA CORP) 21 April 1999 (1999-04-21) column 6, line 3 -column 8, line 37; figures 1A,1B,2,3	1-14
X	US 5 895 530 A (BRYANT TODD C ET AL) 20 April 1999 (1999-04-20) column 3, line 64 -column 8, line 14; figures	1,4,5,9, 10,13

☐ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

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Name and mailing address of the ISA

European Patent Office, P.B. 5618 Patentlaan 2
NL - 2280 HV Rijswijk
Tel. (+31-70) 340-2040, Tx. 31 651 epo nl,
Fax: (+31-70) 340-3016

Authorized officer

Patterson, A

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Patent document cited in search report		Publication date		Patent family member(s)	Publication date
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			EP	0909836 A2	21-04-1999
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